

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

JEONG-HEE LEE et al.

Serial No.: *to be assigned*

Examiner: *to be assigned*

Filed: 12 February 2004

Art Unit: *to be assigned*

For: METHOD OF MANUFACTURING FIELD EMISSION DEVICE

INFORMATION DISCLOSURE STATEMENT

Mail Stop Patent Application

Commissioner for Patents

P.O.Box 1450

Alexandria, VA 22313-1450

Sir:

In accordance with 37 C.F.R. §1.56, and §§1.97 and 1.98 as amended, Applicant cites, describes and provides copies of the following art references:

1. U.S. Patent No. 6,440,761 to Choi, entitled *CARBON NANOTUBE FILED EMISSION ARRAY AND METHOD FOR FABRICATING THE SAME*, issued on 27 August 2002.
2. U.S. Patent No. 6,339,281 to Lee, *et al.*, entitled *METHOD FOR FABRICATING TRIODE-STRUCTURE CARBON NANOTUBE FIELD EMITTER ARRAY*, issued on 15 January 2002.

U.S. Patent No. 6,440,761 to Choi discloses an FEA using a paste mixture of electron emission materials and a method of fabricating the same.

U.S. Patent No. 6,339,281 to Lee *et al.* discloses an FEA and a method of fabricating the

same, in which CNTs formed by growth method are used as emitters.

The citation of the foregoing references is not intended to constitute an assertion that other or more relevant art does not exist. Accordingly, the Examiner is requested to make a wide-ranging and thorough search of the relevant art.

No fee is incurred by this Statement.

Respectfully submitted,



Robert E. Bushnell

Reg. No.: 27,774

1522 "K" Street, N.W., Suite 300
Washington, D.C. 20005
Area Code: (202) 408-9040

Folio: P57030
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